Notice of References Cited	Application/Control No. 10/632,930	Applicant(s)/Patent Under Reexamination FUKUNAGA, TAKESHI	
	Examiner William M. Brewster	Art Unit 2823	Page 1 of 1

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	L	US-			
	M	US-			

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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